



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation Number: 6219

Hiroshi TAKENO

Group Art Unit: 1722

Application No.: 09/926,202

Examiner: Matthew A. ANDERSON

Filed: September 24, 2001

Attorney Dkt. No.: 107242-00024

For: MANUFACTURING PROCESS FOR SILICON EPITAXIAL WAFER

**AMENDMENT AND RESPONSE WITH FILING OF A REQUEST FOR
CONTINUED EXAMINATION (RCE) UNDER 37 C.F.R. § 1.114**

Mail Stop RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: August 25, 2006

Sir:

Prior to continued examination of the above-identified application, please consider the amendments and remarks as shown on the following pages:

Amendments to the Claims begin on page 2.

The Remarks begin on page 6.